

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

---

In re Patent Application of:  
Yutaka TAKAFUJI et al.

Application No.: 10/668,186

Confirmation No.: 4125

Filed: September 24, 2003

Art Unit: 2813

For: SINGLE-CRYSTAL SILICON SUBSTRATE,  
SOI SUBSTRATE, SEMICONDUCTOR  
DEVICE, DISPLAY DEVICE, AND  
MANUFACTURING METHOD OF  
SEMICONDUCTOR DEVICE

---

Examiner: L. M. Schillinger

**AMENDMENT UNDER 37 C.F.R. 1.114**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated January 29, 2008, finally rejecting claims 16, 18-21, 23-27, 29, 36, 38, and 58, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 14 of this paper.